4801:- QSince, Io = Mn Con W (VGS-VTh) Vos (:Deep Triode,
Vos > very Sman)

=) $I_{0_2} - I_{0_1} = \frac{w}{L} \mu_n con' \left[v_{0s_2} - v_{0s_1} \right]$

=) $75 \times 10^{-6} - 35 \times 10^{-6} = \frac{15}{2} \mu_n (6.9 \times 10^{-8}) (2.5 - 1.5) (0.10)$

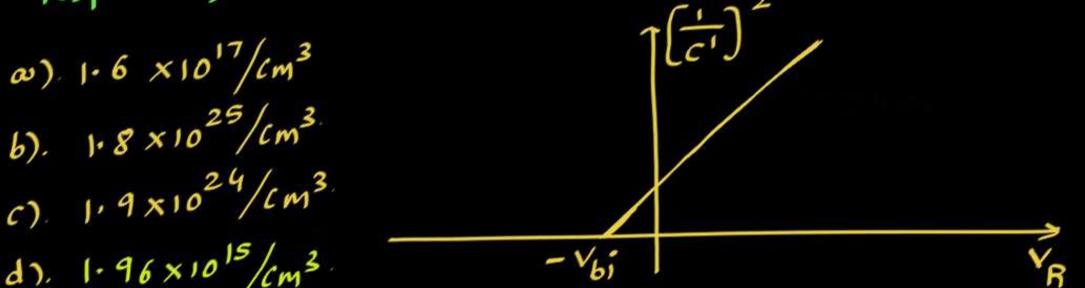
By Asolving Un = 773 cm²/v-sec.

$$\frac{4^{501}}{2^{501}} = \frac{2^{501}}{4^{500}} = \frac{2^{500}}{4^{500}} = \frac{2^{500}}{4^{500}}$$

ophion-a is Correct.

(a). Determine the Impurity doping Concentrations in a ptn Junction Shown in figure. Assume Ubi = 0.7250, alope is 6.15 × 10 (F) 1

respectively, where Openating Temperature T = 300°K.



(211)

Since we know
$$\longrightarrow p^{\dagger}n \longrightarrow Onesided$$

$$=> W = \left[\frac{2\varepsilon}{4}, \frac{1}{N_0}, \left(V_{bi} + V_0\right)\right]^{1/2}$$

where Vo - under RiBias.

As
$$C_{j}' = \left(\frac{q_{e_{s}; N_{0}}}{2(v_{bi} + v_{0})}\right)^{1/2} = 3\left(\frac{1}{C_{j}'}\right)^{2} = \frac{2(v_{bi} + v_{0})}{q_{N_{0}} e_{si}}$$

=>
$$N_D = \frac{2}{9^{2} \cdot 6_{5i}} \cdot \frac{1}{5000} = \frac{2}{1.6 \times 10^{-19} \times 10.7 \times 8.85 \times 10^{-14} \times 6.15 \times 10^{15}}$$

=> $N_D = \frac{2}{1.6 \times 10^{-19} \times 10.7 \times 8.85 \times 10^{-14} \times 6.15 \times 10^{15}}$

As
$$V_{bi} = \frac{kT}{q_i} \frac{\log \left| \frac{N_0 N_A}{n_i^2} \right|}{e}$$

=)
$$N_A = \frac{n_i^2}{N_0} exp(\frac{V_{bi}}{V_T})$$

$$= \frac{(1.5 \times 10^{10})^2}{1.963 \times 1015} exp\left(\frac{0.725}{0.0259}\right)$$

(a). Under n-channel si Mosfet at T=300°K, Assume the Substrate is Doped to NA = 3×10 16/cm3 & tox = 20nm, with UsB=IV. Tyen Find Change in Threshold Voitage? 4801:- There Exist Body Effect. As V_{Th} = V_{Tho} + & [J = Ø_{Fp} + |V_{SB}| - J = Ø_{Fp}] => DVTh = VTh-VTho = 2 [[] 2 pp + | VSB] -) 2 pp]

Psince, $N = \frac{\sqrt{29 \, \epsilon_s; \, N_A}}{\sqrt{6000}}$ where $\delta \epsilon_p = \frac{kT}{q} \log \left| \frac{N_A}{n_i} \right| = 0.3758V$. $C_{0x}' = \frac{\epsilon_0 \left(\epsilon_r \right)_{sio_2}}{t_{ox}} = 1.726 \times 10^7 F/cm^2.$

Now we get
$$\gamma = \left(2(1.6 \times 10^{-19})(11.7)(8.85 \times 10^{-14})(3 \times 10^{-16})\right)^{1/2}$$

Then what is the value of
$$I_{OS} = 2 \times 10^{-4} A$$
, $I_{OS} = 4 \times 10^{-4} A$, $I_{OS} = 4 \times 10^$

(Q). Consider an n-type silicon photoconductor with Length L=1004m, Cross Sectional Area, A=10-cm², Minority like time 7p=10-6sec, (in) with Applied Voitage, U=10V. Caliculate photo conductor gain 9 a). 1.83×10². b). 1.9×10⁴. c). 1.83×10¹². d). 1.9×10³. 4501:- Since Photo Conductor gain = To [1+ MP] where Electron Transit time, $t_n = \frac{\zeta}{4n^E} = \frac{\zeta^2}{4n^V} = \frac{(100 \times 10^{-4})^2}{13.50 \times 10}$

 $Gain = \frac{10^{-6}}{7.41 \times 10^{-9}} \left[1 + \frac{480}{1350}\right] = 1.83 \times 10^{2}$ => Ophion- @.

(a). A long si pn solah cell @ T = 300°k, with NA = 1016/cm3, No=1015/cm3,

Dn = 25 Cm²/sec, Op = 10 cm²/sec, Tno = 10-sec & Tp = 5x10-7 sec. The Cross Sectional Area of Osolar Cell is 5cm2. The generaled Photo Current, $I_{L}=120\text{ mA}$. Determine Haximum Power output of the Solar Cell 9 [Consider leakage current, $I_{S}=8.95\times10^{-10}\text{A}$]. 9 [Consider of mw] 9 [9 [9 [9 [9 [9 [9]] 9 [9]] 9 [9] 9] 9 [9] 9 [9] 9] 9 [9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9 [9] 9] 9] 9 [9] 9] 9] 9 [9] 9] 9] 9 [9] 9] 9] 9 [9] 9] 9] 9 [9] 9] 9] 9] 9 [9] 9where $I_s = 8.95 \times 10^{-10} Amp.$, =) we get $V_m \approx 0.412 V.$ Also, $I_m = I_L - I_S \left(exp \left(\frac{v_m}{v_T} \right) - 1 \right) = 12.75 mA$ · · Pm = Vm Im = 46.5 mw.